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Fission-track etching in apatite: A model and some implications

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ABSTRACT

1 From their formation, fission tracks are complex structures, onto which their thermal histories
2 come to be imprinted. Track etching leaves elongated voids whose lengths and orientations are
3 used for reconstructing these histories. It is thus important to understand etching for interpreting
4 track data. We revive an existing dissolution model which explains the geometries and dimensions
5 of etched fission tracks in apatite. It implies that on continued etching the track contours come to
6 reflect the minimum and maximum apatite etch rates, at the same time that all trace of the track
7 structure is erased. We cannot derive valid etch rates from the dimensions of the track openings
8 or from the length increase of step-etched confined tracks. The roundedness of the track tips is not
9 a measure of etching progress. Understanding the contours of confined tracks does permit in most
10 cases to calculate their true etch times. We propose to exploit this fact to set an etch-time window,
11 and to model the confined-track data in this interval. The excluded measurements will be those of
12 the least-etched and most-etched tracks. This numerical loss is offset by the fact that an etch-time
13 window relaxes the requirement of a fixed immersion time, and a longer immersion multiplies the
14 measurable confined tracks. This calls for no changes to existing procedures if the etch-time
15 windows for different protocols give consistent results. The length data for apatites with different
16 compositions could become comparable if their etch-time windows were linked to a compositional
17 parameter.

Keywords: Apatite, fission track, etching, effective etch time, surface track, confined track

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INTRODUCTION

18 Fission tracks in apatite are $\sim 20 \mu\text{m}$ long (Bhandari et al. 1971; Jonckheere 2003) and $\sim 10 \text{ nm}$
19 wide (Paul and Fitzgerald 1992; Paul 1993; Li et al. 2011; 2012; 2014), too thin to observe with a
20 microscope. Polished grain mounts are therefore etched for fission-track dating and thermal history
21 modelling. Etching creates micrometer-wide channels along the track axes, which can be counted
22 and measured with an optical microscope. The average etchable length of a fission track in apatite
23 is $\sim 16 \mu\text{m}$ or less, depending on the temperatures that it has experienced, but also on its orientation,
24 the apatite composition and the etching protocol (Tamer et al. 2019). The effects of temperature,
25 orientation and composition have been studied and integrated in quantitative models. These
26 studies have become too numerous to list but Tables 5 and 6 of Wauschkuhn et al. (2015) give an
27 overview.

28 Investigations of apatite (Fleischer and Price 1964; Patel et al. 1967), zircon (Krishnaswami et al.
29 1974; Gleadow and Lovering 1977) and titanite (Naeser 1967; Gleadow 1978) showed that track
30 revelation is anisotropic and that the crystallographic orientations of the etched surfaces influence
31 their etching characteristics and the appearance of the etched tracks. Later studies investigated the
32 influence of etching on the track densities, e.g., for apatite: Green and Durrani (1978), Poupeau et
33 al. (1980), Watt and Durrani (1985), Singh et al. (1986), Sandhu et al. (1988a, b), and Jafri et al.
34 (1990). Interest waned after the ζ -calibration was adopted (Hurford 1990a, b), which obviated
35 explicit counting efficiencies. Its intended application to single-grain dating implies that the tracks
36 should be counted in slow-etching faces with high etching efficiencies, e.g., the prism faces of apatite
37 (Gleadow 1981). This is a lasting result of the investigations of anisotropic fission-track etching.
38 Beginning before, but for the most part after the ζ -watershed, etching experiments were aimed at
39 defining suitable protocols for etching confined fission tracks in advance of comprehensive
40 annealing experiments, e.g., Laslett et al. (1984), Green et al. (1986), Crowley et al. (1991), Carlson
41 et al. (1999), Barbarand et al. (2003), Ravenhurst et al. (2003), and Tello et al. (2006). Other
42 studies addressed certain fundamental aspects of fission-track etching in apatite (Hejl 1995;
43 Jonckheere and Van den haute 1996; Jonckheere et al. 2005; 2007; 2017; 2019; Murrell et al.
44 2009; Moreira et al. 2010; Sobel and Seward 2010; Tamer et al. 2019; Tamer and Ketcham 2020;
45 Aslanian et al. 2021).

46 Several models have been proposed to account for the appearance of etched tracks in isotropic and
47 anisotropic detectors. All are based on the premise that the track geometries result from dissolution

48 of the damaged core at a rate v_T (track etch rate) along the track axis and of the undamaged
49 detector at a rate v_B (bulk etch rate) in all other directions. Etched-track profiles were calculated for
50 isotropic v_B and constant and variable v_T (Fleischer et al. 1969; Henke and Benton 1971; Paretzke
51 et al. 1973; Ali and Durrani 1977; Barillon et al. 1997; Nikezić 2000; Nikezić and Yu 2003; Tagami
52 and O'Sullivan 2005; Hurford 2019). Some models describe bulk etching of anisotropic detectors
53 using distinct etch rates parallel (v_P) and perpendicular (v_N) to the surface (Wagner 1969; Somogyi
54 and Szalay 1973; Somogyi 1980; Durrani and Bull 1987; Sawamura and Yamazaki 1994; Ditlov
55 1995) or parallel and perpendicular to the c -axis (Gleadow 1981). Others inferred bulk etch rates
56 from the etched-track geometries (Masumoto 1992; Yamada et al. 1993; Villa et al. 1995; 1997;
57 1999).

58 These studies do not provide a unified model of fission-track etching in minerals and all fail on
59 three counts: (1) none explains the qualitative difference between pitted, scratched and textured
60 surfaces (Gleadow 1978; Jonckheere and Van den haute 1996); (2) none accounts for the different
61 track geometries in different faces, e.g., in the basal and prism faces of apatite (Baumhauer 1875;
62 1887; Mehmel 1932; Jongebloed et al. 1973); (3) none predicts the basic dual structure of etched
63 tracks, consisting of an etch pit and a channel, most obvious in pitted surfaces. We reintroduce a
64 model owed to Gross (1918), show that it accounts for these core properties, use it to predict
65 etched-track profiles in apatite, and compare them with observations. We conclude with some
66 practical implications of etch-rate measurements and calculations of the true etch times of confined
67 fission tracks.

HISTORICAL DEVELOPMENT

68 Fission-track etching is a specific instance of chemical etching, which falls under crystal growth and
69 dissolution¹. This subject has interested scientists for two centuries. Before the diffraction methods
70 of M. von Laue and W. and L. Bragg exposed their internal structures, the understanding of crystals
71 rested on their external properties. At the beginning of the nineteenth century, F. Mohs published
72 observations on the dissolution of rock salt and A. von Widmanstätten on etching of iron meteorites.
73 Daniell (1816) is credited with the first systematic investigation of crystal dissolution, noting that
74 "*the surface of a body is never equally acted upon by a solvent*". Brewster (1837) proposed to use the
75 patterns of light reflected from etched surfaces for investigating their symmetries, observing that

¹ For convenience, we do not distinguish between etching and dissolution.

76 *"different solvents ... produce different figures"*. Lavizzari (1865) first studied the evolving shapes of
77 single-crystal spheres during dissolution. These innovations prompted comprehensive investigations.
78 Goldschmidt and Wright (1903) listed 153 papers by 75 different authors, published since that of
79 Daniell (1816).

80 Etching had practical significance as *"A new method for investigating the structure and composition*
81 *of crystals"* (Leydolt 1855). According to Baumhauer (1894), *"the etching method allows to*
82 *distinguish all 32 crystal classes and is considered superior to optical methods"*. It proved to be most
83 useful for investigating twinned, merohedral and enantiomorphic forms, as recently shown by Hejl
84 (2017a, b) and Hejl and Finger (2018) with reference to fission-track etching in nepheline. Becke
85 (1890) and Baumhauer (1894) summarized the results of earlier studies and formulated empirical
86 principles still relevant to modern investigations of fission-track etching in apatite, titanite and
87 zircon.

88 For given conditions, a crystallographic plane can be assigned a unique growth or dissolution rate
89 v_R . As Masing (1922) proved, v_R is the rate of displacement of the whole plane parallel to itself; v_R
90 is a vector perpendicular to the plane to which it refers. It is for this reason that bulk etch rates v_B
91 cannot be used for anisotropic detectors. Growth and dissolution rates depend on orientation; the
92 envelope of all v_R vectors is a surface called a growth or dissolution surface. Growth and dissolution
93 surfaces are in general characterized by steep minima perpendicular to low-index faces, separated
94 by broad maxima. There exists an overall correspondence between growth and dissolution but,
95 depending on the nature and concentration of the etchant, maxima and minima can be
96 interchanged and their relative magnitudes may also be affected. The faces with the lowest growth
97 rates develop during crystal growth, the faces with high dissolution rates during dissolution. As a
98 result of etching, etch pits develop at defects in slow-etching faces and hillocks on fast-etching
99 faces.

100 Honess' (1927) monograph, *"The nature, origin and interpretation of the etch figures on crystals"*,
101 marks the end of the first mineral investigations based on etching, before diffraction methods took
102 over. Well before then, scientists had begun addressing the theoretical problem of explaining the
103 varied geometries of growing and dissolving crystals. P. Curie and J.W. Gibbs proposed that a solid
104 in equilibrium with its fluid phase adopts an equilibrium form which minimizes the surface energy
105 (capillary force). G. Wulff deduced from this that the growth form of a crystal should be bounded
106 by slow-growing, low-index faces. A. Johnsen, in contrast, observed that non-equivalent faces with

107 identical free energies exhibit different growth and dissolution rates in over- and under-saturated
108 solutions. Gross (1918) concluded that the growth and dissolution forms are the products of kinetic
109 factors, i.e., the relative growth and dissolution rates of the different crystal faces, and developed a
110 kinetic-geometric dissolution model, which we apply in the following sections to fission-track
111 etching in apatite.

112 Etching fell into disuse with the introduction of diffraction methods but regained interest when
113 scientists demonstrated the correspondence between etch-pit and dislocation patterns (Amelinckx
114 1956). This made it a practical tool for investigating defects in semi-conductors and prompted
115 new theoretical work, notably that of Frank (1958; 1972). Frank's topographic approach identifies
116 the orientations of faces with their step densities per unit length. Growth and dissolution are treated
117 as lateral motion of step trains parallel to flat, low-index faces. It follows from a conservation
118 principle that the trajectories of surfaces of a given orientation are straight lines perpendicular to
119 the tangent to a polar plot of the reciprocal etch rates (reluctance plot). The evolution of curved or
120 polyhedral forms during growth and dissolution may be traced in this way. We refer the interested
121 reader to the original publications for a fuller account. A simpler construction was proposed by
122 Jaccodine (1962). Lacmann et al. (1974) went on to suggest that Frank's (1958; 1972) units steps
123 are bounded by equilibrium form faces, thus establishing a relationship between the growth and
124 dissolution forms of a crystal and its equilibrium form (Heimann 1975). Dissolution of apatite is of
125 continuing interest to medical and dental research, agriculture, and to the manufacture of micro-
126 components.

GROSS' KINETIC MODEL

127 Apatite etching in nitric acid is a unidirectional, non-equilibrium process (e.g., Chairat et al. 2007).
128 In this case, dissolution is not defect-assisted but controlled by the intrinsic apatite etch rates (v_R),
129 except along the tracks (v_T). We assume that neither is limited by diffusion in a stirred solution.
130 This reduces track etching to a kinetic-geometric problem. We side-step Frank's (1972) method,
131 because we do not aim to trace the evolution of a track through the etching process, but to predict
132 its contour at the end. This can be achieved with Gross' (1918) older but simpler method, also de-
133 scribed in several later publications (e.g., Masing 1922; Yamamoto 1961; Heimann 1975; Prywer
134 2005).

135 The core assumption is that, for given conditions, v_R is a fixed property of a crystallographic plane,

136 i.e., its rate of perpendicular displacement. Figure 1a illustrates the unit step applied to each point
137 on the surface of a dissolving solid to obtain its form after an etch time t_E : (1) draw a tangent to
138 the surface; (2) measure a distance $d_E = v_R t_E$ perpendicular to the tangent; (3) draw a parallel to
139 the first tangent at the end of d_E ; this is a tangent to the etched form, unless it has been eliminated.
140 Elimination is a consequence of competitive dissolution of adjoining faces. Wulff (1901) explained
141 the elimination of faces of a growing convex form, but the same principle applies to the dissolution
142 of a concave form, such as a confined fission track. Figure 1b, after Wulff (1901) and Alexandru
143 (1969), illustrates this principle: two faces, $F_0(a_0-c_0)$ and $G_0(c_0-e_0)$, at an external angle θ , limit a
144 dissolving concave form $(a_0-c_0-e_0)$. Etching for a unit etch time at rates v_F and v_G advances $F_0(a_0-c_0)$
145 parallel to itself to $F_1(a_1-c_1)$ and $G_0(c_0-e_0)$ to $G_1(c_1-e_1)$, creating an extra section $(b_1-c_1-d_1)$. F and G
146 both increase in lateral extent if their intersection c_1 lies in the sector θ $(b_1-c_0-d_1)$; $\Delta F = (b_1-c_1)$ and
147 $\Delta G = (c_1-d_1)$:

$$\Delta F = \frac{v_G - v_F \cos \theta}{\sin \theta} \quad (1)$$

$$\Delta G = \frac{v_F - v_G \cos \theta}{\sin \theta} \quad (2)$$

148 If c_1 does not lie in the sector θ $(b_1-c_0-d_1)$, then F grows at the expense of G if $v_F < v_G \cos \theta$ (Figure
149 1b, $c_0-b_0-d_1$), or G grows at the expense of F if $v_G < v_F \cos \theta$ (Figure 1b, $c_0-d_0-b_1$). Figure 2, after
150 Masing (1922), depicts consecutive dissolution stages of a concave polygonal initial form $F_0(a_0-b_0-$
151 $c_0-d_0-e_0-f_0)$. Its faces are perpendicular to the etch-rate minima, and able to withstand the
152 encroachment of vicinal faces with much higher etch rates. However, the polygon faces compete
153 among themselves and (b-c) and (d-e), with somewhat higher etch-rate minima, lose out to (a-b),
154 (c-d) and (e-f). When etching has advanced to $F_1(a_1-c_1-d_1-f_1)$, (b-c) and (d-e) have been eliminated
155 from the dissolving form. It is worth noting that (c-d) grows at the expense of (b-c) and (d-e) up to
156 F_1 , but thereafter shrinks because it cannot hold its own against the slowest-etching faces (a-b)
157 and (e-f).

158 Figure 3 illustrates Gross' (1918) method applied to circular forms. The quadrants shown present
159 all orientations over a 90° angle to the etchant. The etch-rate plots show the etch rates parallel to
160 an apatite prism face as a function of the c -axis angle (Aslanian et al. 2021). Figures 3a-c refer to a
161 concave initial form (F_0), e.g., a cross-section through a cylindrical hole perpendicular to the c -axis.
162 As in Figure 1a, each T-shape represents the parallel displacement of a surface section over a

163 distance proportional to the perpendicular etch rate. The envelope of the displaced surface sections
164 defines the etch stage F_1 . The steep etch-rate minimum parallel to c enlarges the basal face at the
165 expense of neighbouring orientations. The less pronounced minimum perpendicular to c has a less
166 extreme but similar effect. In Figure 3b, a second, identical etch step is applied to F_1 , giving F_2 ; the
167 basal and prism faces expand further so that little remains of the initial circular cross-section. This
168 illustrates that concave forms come to be bounded by low-index faces perpendicular to the etch-
169 rate minima, an empirical fact established before Becke (1890). Figure 3c shows that a single etch
170 step with the combined etch action of the first ($F_0 \rightarrow F_1$) and second ($F_1 \rightarrow F_2$) gives the same result
171 ($F_0 \rightarrow F_2$). This illustrates that a superposition principle applies to Gross' (1918) construction. This
172 means that we can obtain etched-track shapes in one step, without having to consider intervening
173 stages. Figures 3d ($F_0 \rightarrow F_1$), 3e ($F_1 \rightarrow F_2$) and 3f ($F_0 \rightarrow F_2$) show the corresponding dissolution stages
174 of a convex form, e.g., a solid apatite cylinder perpendicular to the c -axis, etched on the outside. In
175 contrast to the concave form, the surfaces with the highest etch rates expand at the expense of
176 adjacent ones. The slowest-etching faces are eliminated first and edges (corners in 3D) develop
177 opposite the etch-rate minima. In contrast to the concave form, the areas between the edges retain
178 some curvature. This is because the etch-rate maxima are flatter than the cusp-shaped minima, in
179 accordance with the fact that the former correspond to high-index planes and the latter to low-
180 index planes.

SURFACE-TRACK GEOMETRIES

181 Figures 4 to 6 illustrate Gross' (1918) construction applied to fission-track etching, using the etch-
182 rate data of Aslanian et al. (2021) for Durango apatite etched in 5.5 M HNO_3 at 21 °C. Figures 4a and
183 4b show a track intersecting a basal surface at a 60° angle; the dash-dotted line is the axis of the
184 latent track (t -axis). The thick solid line is the calculated track profile in the plane containing the
185 track axis and apatite c -axis. The clover leaf is the envelope of the apatite etch rates in different
186 orientations. The shaded sector spans the etch rates that are relevant to the dissolution of apatite
187 at the surface intersection and the end of the track. It includes the etch rate perpendicular to the
188 surface, which determines the extent of surface lowering, and the etch rates perpendicular to the
189 track axis, which determine the rate of channel widening. The shaded sector also includes the
190 intermediate orientations, which exist at the surface intersection and at the end of the track. These
191 orientations have zero initial extent but expand as etching proceeds, i.e., the converse process of
192 the elimination of faces in Figure 2. The sectors highlighted in green contribute to the final shape of

193 the track. At the surface intersection the faces perpendicular to the maximum etch rates advance
194 farthest into the apatite, forming an etch pit. No single face outcompetes all its neighbours so that
195 the etch pit walls are slightly curved. The shape of the concave track tip, in contrast, is for the most
196 part controlled by the steep etch-rate minima perpendicular to the basal and prism planes. The
197 latter minimum is less pronounced, which permits neighbouring slow-etching faces, highlighted in
198 green, to produce curvature at the connection between the track channel and the terminating prism
199 face. Figure 4b presents the calculated profile of the same track in the plane perpendicular to that of
200 Figure 4a.

201 Figure 5 shows a track intersecting a prism surface at 60° . Figure 5a shows the plane perpendicular
202 to the surface containing the *t*- and *c*-axes; Figure 5b shows the track as seen along the *c*-axis. The
203 clover leaf in Figure 5a again represents the apatite etch rates in a prism plane. The circular etch-
204 rate plot in Figure 5b signifies that the etch rate shows negligible dependence on orientation about
205 the *c*-axis. We have as yet no data on the etch rates of different prism faces, but it is reasonable to
206 assume that all prism planes etch at a similar rate, given the uniform channel widths in a basal plane,
207 compared to the striking variation of track width with orientation in a prism plane. The *t*-axis is
208 almost perpendicular to the maximum etch rates in the prism plane (Figure 5a). Etching thus
209 produces a broad channel, so that no etch pit can develop at the intersection with the surface (thick
210 dashed lines). The end of the track is made up of a basal and a prism plane, which are perpendicular
211 to the etch-rate minima. The intersection between the bounding basal plane and the channel wall is
212 angular; that between the bounding prism plane and the opposite channel wall is rounded. These
213 details depend on the orientation of the track and on the variation of the etch rate about the minima.
214 Figure 5b shows that the track is caught between a pair of slow-etching prism faces. This, together
215 with the much greater channel width in the prism plane (Figure 5a), produces the characteristic knife-
216 blade shape.

217 Figure 6 shows a track perpendicular to the *c*-axis intersecting a prism surface. Like all tracks, it is
218 caught between a pair of prism planes (Figure 6b), and in this specific case, between a pair of basal
219 planes as well (Figure 6a). Thus, rather than a knife-blade shape, the track channel acquires a needle
220 shape bounded by two pairs of slow-etching faces. Because of the narrow channel, a distinct etch pit
221 made up of planes perpendicular to the etch-rate maxima develops at the track-surface intersection.
222 Such maxima exist in the prism plane (Figure 6a) but not perpendicular to it (Figure 6b). The etch
223 pit can thus grow in the *c*-axis direction but not in a perpendicular direction, conveying it the shape

224 of a flat funnel. In loose terms, etch pits in a prism face are two-dimensional (flat), in contrast to
225 those in a basal surface, which are three-dimensional (Figure 4). Because of this flattened shape and
226 because they are often encompassed in the broad etch channels, etch pits in a prism surface are less
227 conspicuous than in a basal face, and the apatite prism face is not considered as a pitted face despite
228 its low etch rate.

229 Gross' (1918) construction thus accounts for most properties of etched surface tracks in apatite, viz.
230 their dual structure, consisting of a convex etch pit and a concave channel, and the fact that their
231 shapes depend on the orientation of the surface and of the track (Figure 7). The shaded sectors of
232 the etch-rate plots indicate the range of etch rates competing to form the etched track. For a dip
233 angle θ this range spans the interval $[\theta - \pi/2, \theta + \pi/2]$. The sectors highlighted in green are the
234 etch rates that win out and determine the shapes of the etch pit and the track ending. These are
235 dominated by the orientations of the maximum and minimum etch rates. Gross' (1918) model
236 does not explain the formation of pitted, scratched and textured surfaces because it assumes that,
237 as it advances parallel to itself, a surface remains even and flat. Equations (1) and (2) nevertheless
238 entail that etch pits form in slow-etching faces and hillocks grow on fast-etching faces (Jonckheere
239 and Van den haute 1996). Gross' (1918) model also accounts for the knife-blade shapes of etched
240 tracks (Figures 4-6).

CONFINED-TRACK CONTOURS

241 Gross' (1918) model allows us to interpret confined-track contours and to estimate their effective
242 etch times. Figure 8a shows a characteristic track-in-track in a prism face. The end ($\alpha\beta$) farthest
243 from the host track intersection (ι) is made up of sections corresponding to the etch-rate minima
244 parallel and perpendicular to the c -axis. A different termination ($\delta\epsilon$) forms at the end closest to the
245 host track intersection due to fast-etching faces advancing from (ι). The midsection has straight
246 sides ($\beta\gamma$ and $\epsilon\eta$), without the least curvature resulting from a decreasing or increasing track-etch
247 rate v_T (Fleischer et al. 1969; 1975); ($\beta\gamma$) and ($\epsilon\eta$) converge away from (ι); the enclosed angle
248 (4.4°) corresponds to a ratio $v_T/v_R = \arctan(4.4/2) \approx 25$. For $v_R \approx 3.0 \mu\text{m min}^{-1}$ at 69° to c (Aslanian
249 et al. 2021), this gives $v_T \approx 75 \mu\text{m min}^{-1}$, within the v_T range of Aslanian et al. (2021). At this rate, it
250 took 10 s to etch the $12.6 \mu\text{m}$ from (ι) to the end ($\alpha\beta$) and under 3 s from (ι) to (δ). It took 33 s to
251 etch the track to its greatest width ($t_E = \frac{1}{2} \times 3.3 \mu\text{m} / 3.0 \mu\text{m min}^{-1} = 33 \text{ s}$). This is 12 s less than the
252 immersion time ($t_I = 45 \text{ s}$), which were needed for etching down the host track and across to the

253 confined track. It follows that etching lasted for 23 s (33 s - 10 s) at ($\alpha\beta$) and 30 s (33 s - 3 s) at (δ).
254 The track-length increase is thus difficult to predict, whichever track-etch (v_T) model one favours
255 (Masumoto 1992; Jonckheere et al. 2017; Tamer et al. 2019; Tamer and Ketcham 2020; Aslanian et
256 al. 2021). A better understanding of track etching nevertheless permits a fuller characterization of
257 confined tracks than just their measured lengths and orientations. The effective etch time (t_E) and
258 position of the intersection point (l) are relevant for estimating overetching (Laslett et al. 1984;
259 Yamada et al. 1993).

260 Figure 8b shows a track at a low angle to c , with straight sides which join onto short sections parallel
261 to c ($\alpha\beta$ and $\gamma\delta$) towards both ends. Its slender form makes it difficult to estimate v_T but it is possible
262 to calculate t_E from its width (0.6 μm) and the widening rate at 8.6° to c (0.75 $\mu\text{m min}^{-1}$; Aslanian et
263 al. 2021). This gives $t_E = \frac{1}{2} \times 0.6 \mu\text{m} / 0.75 \mu\text{m min}^{-1} = 24$ s. The confined track in Figure 8c illustrates
264 the characteristic shape of tracks almost perpendicular to the c -axis. The funnel on one side of the
265 host track (l) consists of a channel ($\kappa\alpha\beta$) and an etch pit bounded by the fastest-etching faces ($\beta\gamma$)
266 and ($\kappa\eta$). The funnel ($\gamma\delta$ and $\epsilon\eta$) on the opposite side of (l) has consumed the channel. It is difficult
267 to determine t_E from the channel width; t_E can instead be calculated from the distances between
268 parallel edges bounding the funnels on both sides of the host track: 3.6 μm between ($\beta\gamma$) and ($\epsilon\eta$),
269 and 3.7 μm between ($\gamma\delta$) and ($\kappa\eta$). For the maximum etch rate (3.05 $\mu\text{m min}^{-1}$; Aslanian et al. 2021)
270 this corresponds to 35 - 36 s. The surviving channel section is too short and thin for estimating v_T .
271 Moreover, v_T cannot be calculated from the angle between ($\beta\gamma$) and ($\kappa\eta$) or ($\gamma\delta$) and ($\epsilon\eta$) either.
272 These angles separate the maximum etch rates to either side of the c -axis in the v_R plot (Aslanian et
273 al. 2021).

274 Figure 8d shows a track almost perpendicular to the c -axis, but with a less regular shape than that in
275 Figure 8c. Overlaying the slowest-etching ($\alpha\beta$, $\delta\epsilon$) and fastest-etching ($\gamma\delta$, $\kappa\lambda$) orientations reveals a
276 diamond shape truncated by a basal face ($\delta\epsilon$). This can be understood as a consequence of the offset
277 of the latent host track relative to the latent confined track. The growth of fast-etching funnel faces
278 requires convex intersections. In contrast to surface tracks (Figure 6a), these exist at confined tracks
279 to the extent that the etched host track created them. On this assumption, the effective etch time can
280 be calculated from the perpendicular distances between ($\gamma\delta$) and ($\kappa\lambda$) and between ($\epsilon\eta$) and ($\lambda\mu$).
281 The result is $t_E = \frac{1}{2} \times 2.3 \mu\text{m} / 3.05 \mu\text{m min}^{-1} = 23$ s, i.e., 12 s less than the track in Figure 8c, consistent
282 with the offset of the host and the confined track. Figure 8e illustrates the case of a confined track
283 sub-parallel to a fast-etching apatite face. All straight contour sections correspond either to slow-

284 etching faces ($\alpha\beta$, $\delta\varepsilon$) or to fast-etching faces ($\beta\gamma$, $\varepsilon\eta$). Its effective etch time can nevertheless be
285 calculated as before (37 s), but v_T -estimates based on the angles between facing edges of the track
286 contour would be invalid. The track in Figure 8f is even more problematic, and appears to offer no
287 hold for calculating either t_E or v_T because it lacks facing channel walls (as in Figures 8a, b) and
288 facing funnel edges (as in Figures 8c, d, e). A tentative t_E estimate is nevertheless possible; section
289 ($\varepsilon\eta$) is parallel to the track axis and does not correspond to a slow-or a fast-etching orientation. It
290 must thus be interpreted as one side of the track channel and its distance to the track axis ($0.7 \mu\text{m}$) is
291 half the track width. With the apatite etch rate for an 80° c -axis angle ($2.1 \mu\text{m min}^{-1}$; Aslanian et al.
292 2021), this gives $t_E = 0.7 \mu\text{m}/2.1 \mu\text{m min}^{-1} = 20$ s. Although the track in Figure 8f is not exceptional,
293 Gross' (1918) model does not explain how segment ($\eta\kappa$) results from etching a straight latent fission
294 track.

295 Gross' (1918) model enables us to interpret the appearances of etched confined tracks and to gain
296 numerical data. Most tracks are straightforward but some at high c -axis angles must be interpreted
297 with care. Gross' (1918) model also casts a light on common misconceptions about track etching.
298 Foremost that "*the shape (cross-section) of an etch pit is the manifestation of the etching velocity*
299 *space (etch-rate plot) characterizing a particular track detector (and etchant)*" (Yamada et al.
300 1993). According to Gross (1918), a track cross-section is a concave form bounded by the slowest-
301 etching faces. So, we cannot calculate other etch rates from the track openings (Singh et al. 1986;
302 Barbarand et al. 2003; Ravenhurst et al. 2003). Nor can we infer apatite etch rates from the length
303 increase of step-etched confined tracks (Laslett et al. 1984; Watt and Durrani 1985; Carlson et al.
304 1999; Tamer and Ketcham 2020). The roundedness of track tips is not a valid measure of etching
305 progress because, on continued etching, the track tips come to be bounded by basal and prism faces.
306 Earlier studies have reported that the rate of increase of the confined-track length does not
307 correspond to the etch rate estimated from the track openings (Masumoto 1992; Yamada et al.
308 1993; Ravenhurst et al. 2003). On the basis of meticulous single-track step-etch experiments
309 Yamada et al. (1993) interpreted rounded track ends in zircon as due to a decrease of the track-etch
310 rate, related to the discontinuous nature of latent tracks towards the ends of the fission-fragment
311 ranges. Despite the support from latent-track studies (Paul and Fitzgerald 1992; Paul 1993; Li et al.
312 2011; 2012) and step-etch experiments (Jonckheere et al. 2017; Aslanian et al. 2021), this fact is still
313 underappreciated, given that the rate of track-length increase is most important for deciding on an
314 etch protocol (Tamer et al. 2019).

315 Figure 9 illustrates that the surface-track openings and channels, and the confined-track contours, are
316 all made up of straight sections. Following a 15 s etch step from 30 s to 45 s immersion, each straight
317 edge has moved parallel to itself over a perpendicular distance which depends on its orientation, as
318 Gross (1918) demanded. The fast-etching sides of the funnel at the intersection of the confined track
319 with the host track expand at the expense of the slow-etching faces flanking the channel (Figure 1b).
320 D_{PAR} increases 1.6 μm (4.0 to 5.6 μm) during 15 s etching, while the confined-track channel widens
321 0.2 μm (0.2 to 0.5 μm) in the same direction. One D_{PER} increases 0.4 μm (1.0 to 1.4 μm), comparable
322 to the increase of the confined-track length in the same direction (0.5 μm), another however 1.1 μm
323 (1.9 to 3.0 μm). This illustrates that D_{PER} (and D_{PAR} ; Murrell et al. 2009; Sobel and Seward 2010;
324 Jonckheere et al. 2020) exhibits variation from track to track. Thus neither D_{PER} or D_{PAR} represent the
325 apatite etch rate in the direction in which they are measured. The break between the confined-track
326 funnel and channel shifted along the track during the 15 s etch step. These features are therefore not
327 related to unetchable gaps in the middle of the track (Hejl 1995). The curvature at both ends of the
328 confined track is similar after 30 s immersion, but dissimilar after 45 s. The roundedness of the track
329 ends is thus not a unique or valid measure of its etching progress. In the 15 s between 30 s and 45 s
330 immersion, the distance between parallel sections of the funnels at the intersection of the confined
331 track with the host track almost doubles, from 1.8 μm to 3.5 μm (Figure 9). This means that the
332 track was in fact etched for a little over 15 s after 30 s immersion. With the etch-rates of Aslanian
333 et al. (2021) we calculate an effective etch time $t_E = 18$ s and an average rate of length increase $v_L =$
334 2 $\mu\text{m min}^{-1}$. Using this approach we can also calculate t_E and v_L for other confined tracks (Aslanian
335 et al. 2021).

IMPLICATIONS

336 Fission-track etching is often referred to as track revelation, in the sense of exposing something
337 hidden from view. It is usually considered an inconsequential step in the preparation of samples for
338 dating and (T,t)-modelling. From their formation, fission tracks are complex and varied structures
339 onto which their thermal histories are imprinted in the form of structural modifications. Etching
340 leaves little more than a cavity of a given shape and dimensions. Gross' (1918) etch model predicts
341 that on continued etching the track contours come to reflect the minimum and maximum apatite
342 etch rates. At the same time, and in contrast to isotropic detectors, all trace of the track-etch rate
343 v_T , and with it of the latent-track structure, is lost. Fission-track etching is therefore far from
344 inconsequential, and it is important to understand the etching process for interpreting track-

345 length data.

346 We described Gross' (1918) kinetic dissolution model, applied it to fission-track etching in apatite
347 and showed that the results agree with microscopic observations. In principle, their effective etch
348 times t_E and rates of length increase v_L allow us to normalize confined-track lengths to a reference
349 etch time. We can in this manner reduce the scatter of track-length data although most of it is due
350 to uranium fission and track formation (Wagemans 1991; Ziegler et al. 1985). Measuring the
351 length increase of fossil tracks can be useful if v_L reflects the order in which tracks formed, i.e., if
352 older tracks have lower v_L than younger tracks (Jonckheere et al. 2017). However, calculating v_L
353 involves two etch steps because it differs from track to track (Aslanian et al. 2021). It therefore
354 seems more practical to settle for a t_E estimate based on a single step if the apatite etch rates v_R are
355 known. This would permit the setting of an etch-time window and modelling of confined track
356 data in the selected interval. For a well-chosen window, the excluded lengths will be those of the
357 least-etched and most-etched tracks. This numerical loss is offset by the fact that an etch-time
358 window eliminates the need to control the immersion time. A longer immersion time brings a
359 rapid increase of the number of measurable confined tracks, including ones within the etch-time
360 window (Ito 2004; Jonckheere et al. 2007). Apart from the immersion time, the proposed method
361 requires no changes to existing procedures if an appropriate window can be defined for each
362 protocol so as to give consistent results. This is, in our opinion, not problematic for common
363 protocols that are not too different to start with (Tamer et al. 2019). We expect that track-length
364 data for apatites with different chemical compositions will become more uniform if their etch-time
365 windows are linked to D_{PAR} or another compositional indicator (Carlson et al. 1999; Barbarand et
366 al. 2003). In the ideal case, this could make compositional annealing corrections redundant. It is
367 however essential for the acceptance of the proposed method that it be based on more extensive
368 experimental data.

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584

FIGURE CAPTIONS

585 **Figure 1.** Construction of etched-track contours. **(a)** Unit step: each tangent to the initial form (F_0),
586 e.g., at a_0 , is shifted parallel to itself over a perpendicular distance proportional to the etch time t_E
587 and etch rate v_R . The parallel face at a_1 is tangent to the etched track (F_1) if it is not eliminated by
588 etching of the faces adjacent to a_0 (Figure 2). **(b)** Etching of a concave intersection between two
589 faces. During etching, F_0 (etch rate v_F) and G_0 (etch rate v_G), intersecting at c_0 , advance to F_1 and
590 G_1 , intersecting at c_1 . Both increase in extent if c_1 lies in the sector θ subtended by lines normal to
591 F_0 and G_0 through c_0 . The dashed lines and highlighted right-angle triangles illustrate limiting
592 cases where either F_0 or G_0 neither grows nor shrinks. A numerical treatment permits the deriva-
593 tion of equations (1) and (2), defining the criteria for growth or shrinkage (modified after Wulff
594 1901, and Alexandru 1969).

595 **Figure 2.** Etching of a concave polygonal shape $F_0(a_0-b_0-c_0-d_0-e_0-f_0)$ with etch-rate minima v_{ab} , v_{bc} ,
596 v_{cd} , v_{de} , and v_{ef} perpendicular to (a_0-b_0) , (b_0-c_0) , (c_0-d_0) , (d_0-e_0) , and (e_0-f_0) . Due to its lower etch rate
597 (v_{cd}), (c_0-d_0) grows at the expense of adjacent faces (b_0-c_0) and (d_0-e_0) with somewhat higher etch
598 rates (v_{bc} and v_{de}). At stage $F_1(a_1-c_1-d_1-f_1)$, (c_1-d_1) enters in competition with (a_1-c_1) and (d_1-f_1) with
599 still lower etch rates (v_{ab} and v_{ef}). Its growth is reversed and (c_1-d_1) shrinks to (c_2-d_2) and will be
600 eliminated in time (after Masing 1922). Lower left: etch-rate plot (dissolution surface) showing the
601 etch-rate minima v_{ab} , v_{bc} , v_{cd} , v_{de} , and v_{ef} , and broad etch-rate maxima, m , n , o , and p , separating the
602 steep minima.

603 **Figure 3.** Etching of a curved surface; the etch rates are those measured as a function of c -axis angle
604 in an apatite prism face etched in 5.5 M HNO_3 at 21 °C (Aslanian et al. 2021). **(a-c)** Concave circular
605 form; **(a)** first etch step starting from the initial circular quadrant (shape F_0) leading to stage F_1 . F_0
606 is approximated by nineteen tangents at 5° intervals each translated proportional to the perpen-
607 dicular etch rate as indicated by the T-shapes (Figure 1a). The etched form F_1 is the inside tangent
608 to all the translated surface sections. Some fast-etching ones are cut by the slow-etching basal face
609 perpendicular to c , reducing F_1 to seven of the original nineteen sections. **(b)** second, identical etch
610 step applied to F_1 , resulting in F_2 ; **(c)** a single step with the combined etch time of $F_0 \rightarrow F_1$ and $F_1 \rightarrow F_2$
611 gives the same result as two successive steps. **(d-f)** Convex circular initial form; **(d)**: first etch step
612 from F_0 to F_1 ; **(e)**: second etch step from F_1 to F_2 ; **(f)**: one step with the combined duration of $F_0 \rightarrow F_1$
613 and $F_1 \rightarrow F_2$. These constructions illustrate that concave forms come to be bounded by flat faces

614 perpendicular to the etch-rate minima, whereas edges and corners develop opposite the minima
615 on a convex form. For clearer illustration, $F_0 \rightarrow F_1$ and $F_1 \rightarrow F_2$ each correspond to two and $F_0 \rightarrow F_2$ to
616 four etch-time units in **(a-c)**, while $F_0 \rightarrow F_1$ and $F_1 \rightarrow F_2$ correspond to one half and $F_0 \rightarrow F_2$ to one full
617 etch-time unit in **(d-f)**.

618 **Figure 4.** Profiles of a track intersecting an apatite basal face at 60° . **(a)** Plane containing the track *t*-
619 axis and *c*-axis; **(b)** plane perpendicular to **(a)** containing the *c*-axis. The etch channel widens at the
620 rate perpendicular to the *t*-axis; the shaded etch rates indicate the faces that can expand from the
621 surface intersection and endpoint. Those highlighted in green are the faces that determine the re-
622 sult. This is a knife-blade shaped channel, connected to the apex of a low upside-down pyramid
623 with somewhat curved walls. The end of the track is bounded by edges parallel to the prism and
624 basal face.

625 **Figure 5.** Profiles of a track intersecting an apatite prism face at 60° . **(a)** Plane of the track axis
626 and *c*-axis; **(b)** plane perpendicular to the *c*-axis. The channel widens at a rate close to the maxi-
627 mum etch rate, preventing an etch pit from developing at the surface. The track is knife-blade
628 shaped and terminated by basal and prism faces. One side of the channel meets the basal face at
629 an angle, while the facing side gradually joins onto the prism face. This difference is a conse-
630 quence of the less pronounced etch-rate minimum perpendicular to the prism face than perpen-
631 dicular to the basal face.

632 **Figure 6.** Profiles of a track intersecting an apatite prism face at 60° . **(a)** Plane of the track axis and
633 apatite *c*-axis; **(b)** plane perpendicular to the *c*-axis. This track is flanked by a pair of basal faces as
634 well as a pair of prism faces. In this case, the etch channel is not knife-blade shaped but needle
635 (rod) shaped, allowing a distinct etch pit to develop. Because there are no pronounced etch-rate
636 maxima or minima in the plane perpendicular to *c*, the etch pit develops noticeably only parallel to
637 the *c*-axis.

638 **Figure 7.** Etched surface tracks in apatite. **(a)** transmitted-light microphotograph of tracks in a basal
639 surface with a funnel shape, consisting of a shallow etch pit connected to a channel (dark; cf. Figure
640 4); the channel width shows little variation with the azimuth orientation of the track, indicating
641 that the etch rates of the flanking prism faces are similar; the tracks indicated with an arrow have
642 no channel because the track endpoint has been overtaken by the growth of the etch pit, which in

643 agreement with Gross' (1918) dissolution model develops a flat bottom parallel to the basal face;
644 the terraced internal structure of these etch pits still reveals the orientation of the latent tracks and
645 suggests intermittent etching at the track endpoints; **(b)** compressed transmitted-light image stack
646 of tracks in a prism face; the yellow arrows indicate etched tracks close to perpendicular to the c -
647 axis with a funnel shape, consisting of an elongated etch pit and narrow channel (cf. Figure 6); the
648 green arrows indicate tracks at intermediate angles to c , exhibiting the characteristic knife-blade
649 shape (cf. Figure 5); the red arrows indicate tracks at low angles to c , in which the knife-blade is
650 seen edge-on.

651 **Figure 8.** Horizontal confined fission tracks in prism faces of Durango apatite etched for 45 s in
652 5.5 M HNO_3 at 21 °C. **(a)** shows a track with a straight channel with subparallel sides, terminated
653 by a basal and a prism face at one end; the opposite end has a more complex shape due to the inter-
654 ference of the slow-etching faces developing at the endpoint and fast-etching faces advancing from
655 the nearby host-track intersection (i). This does not prevent measurement of the track width
656 ($3.3 \mu\text{m}$) close to (i) and the taper of the track channel (4.4°), from which its effective etch time t_E
657 and etch rate v_T can be estimated (Aslanian et al. 2021). **(b)** shows a thin track at a small angle to c ,
658 for which it is difficult to measure the angle between the sides of the track channel, although meas-
659 uring the track thickness is possible. **(c)-(f)** show tracks at angles greater than 75° to c , bounded by
660 combinations of fast-etching and slow-etching faces. Track etch rate estimates are often not possi-
661 ble, but, with a model-based understanding of the track-etching process, it is possible in most cases
662 to interpret their contours, and calculate their effective etch times with adequate precision (see
663 text). Green: slowest-etching faces; yellow: fastest-etching faces; orange: unexplained section of the
664 track contour; all lengths are in μm , and all angles in degrees ($^\circ$).

665 **Figure 9.** Surface tracks and a horizontal confined track in a prism face of Durango apatite after **(a)**
666 30 s and **(b)** 45 s immersion in 5.5 M HNO_3 at 21 °C. Except for the ends of the confined track, their
667 contours are all made up of straight sections. Regardless of their changed dimensions, corresponding
668 sections are parallel after 30 s and 45 s etching, i.e., each maintains its orientation. Their displace-
669 ment varies with orientation demonstrating that the apatite etch rate is anisotropic, consistent
670 with Gross' (1918) dissolution model. The dotted lines are the contours of the track openings and
671 of the confined track after 45 s **(a)** and 30 s immersion **(b)**; all lengths are in μm , and all angles in
672 degrees ($^\circ$).

FIGURES

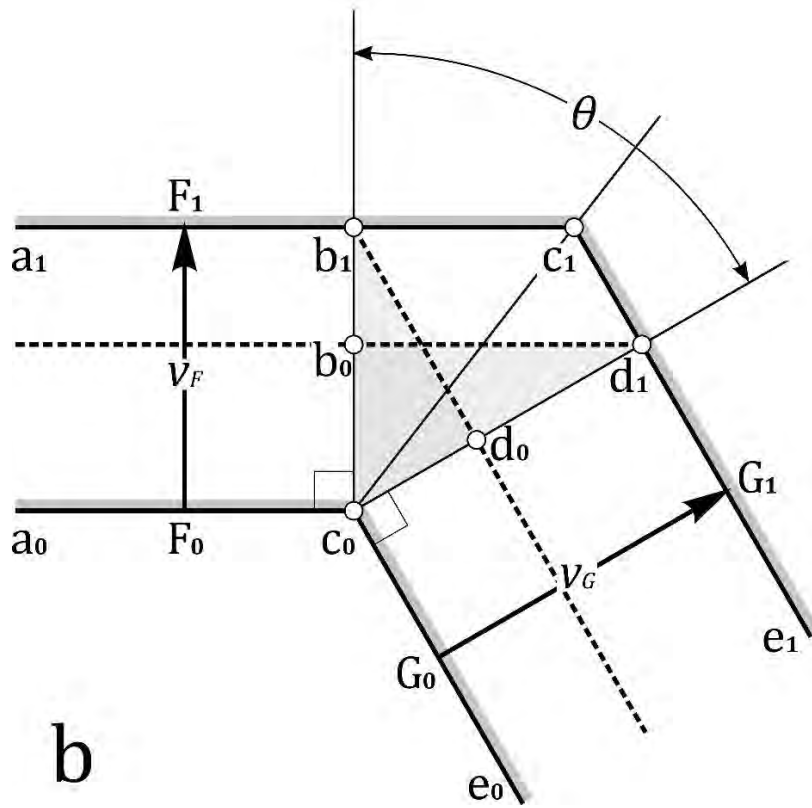
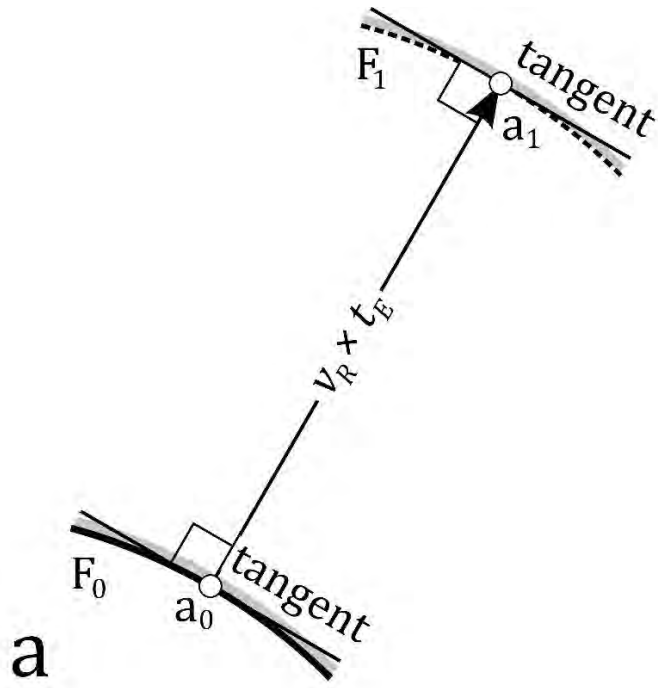


Figure 1

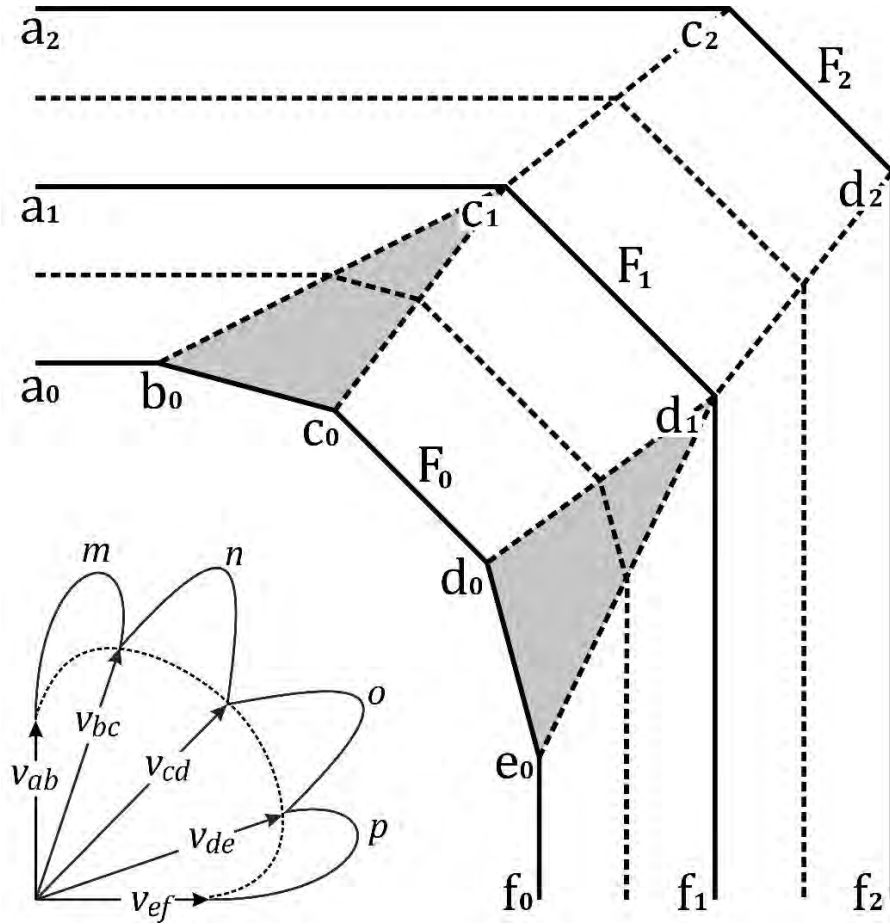
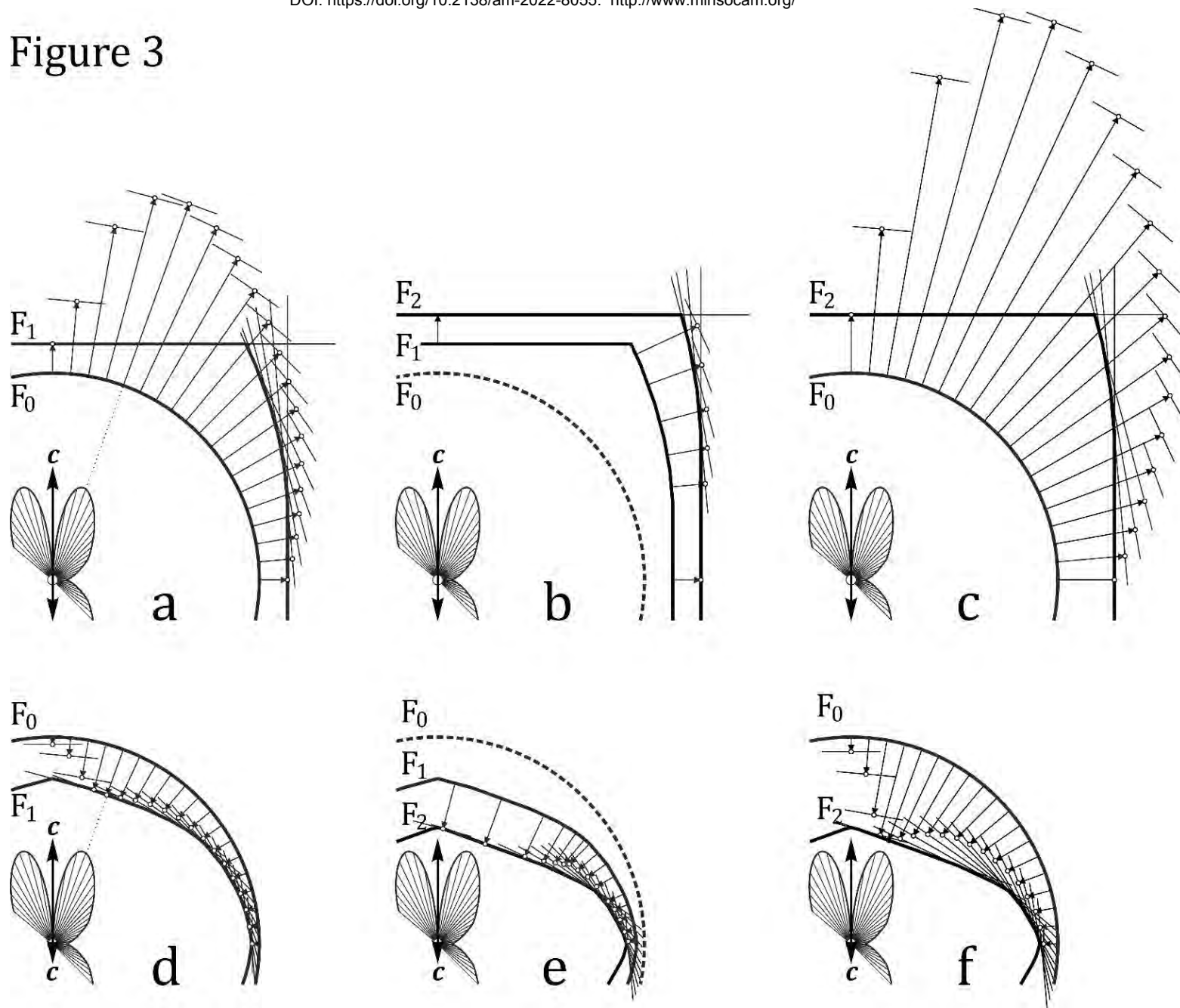


Figure 2

Figure 3



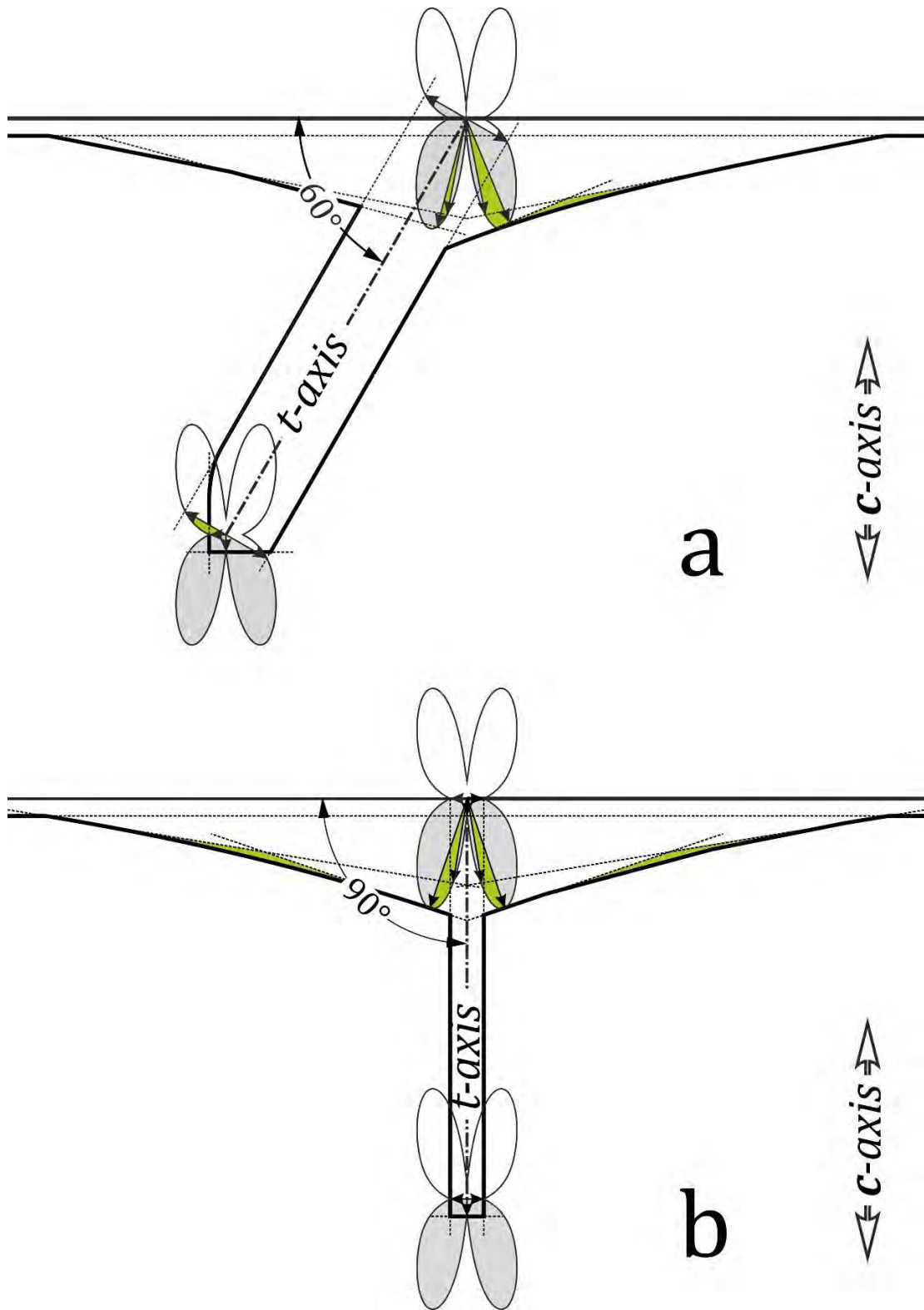


Figure 4

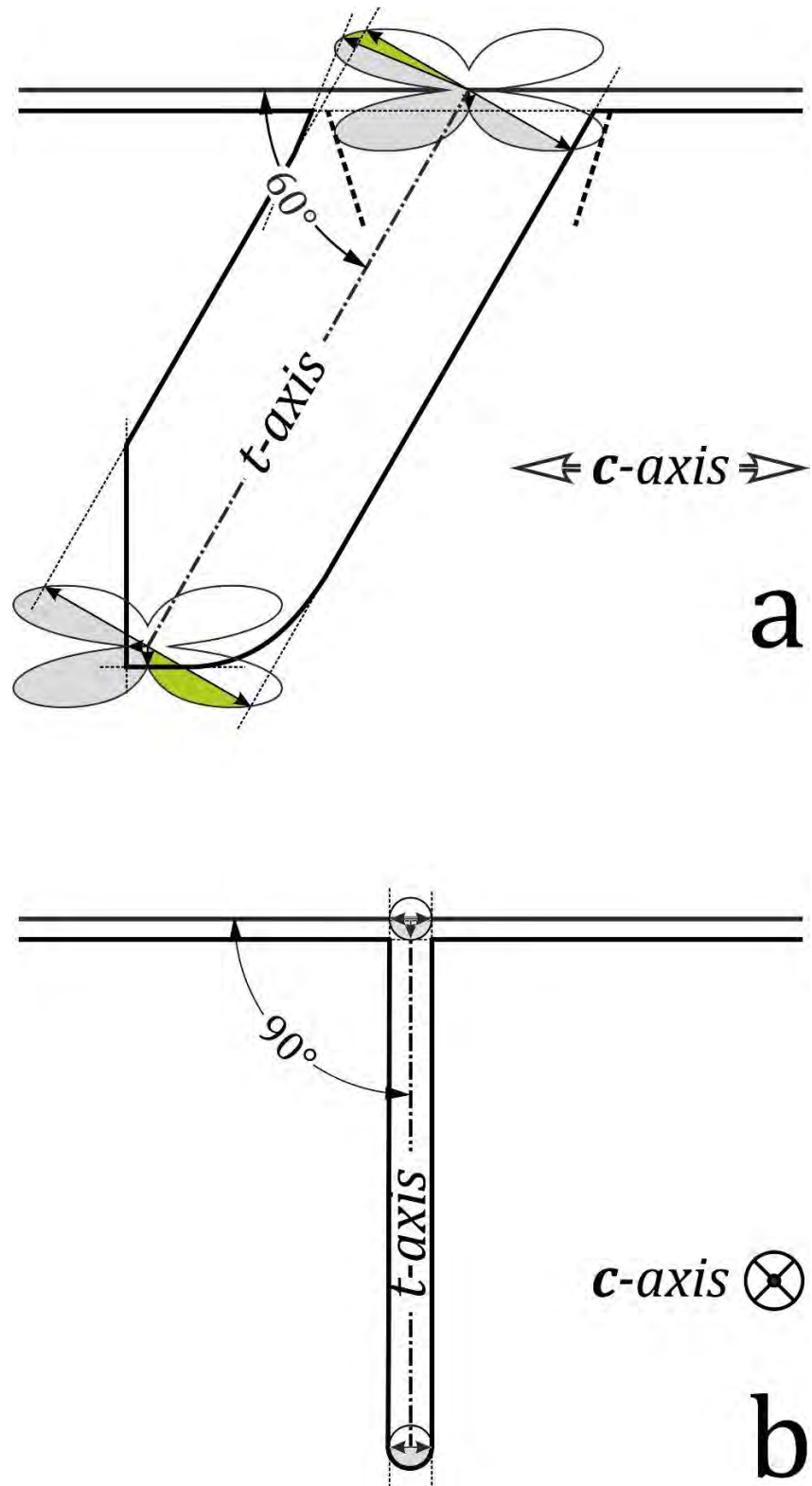


Figure 5

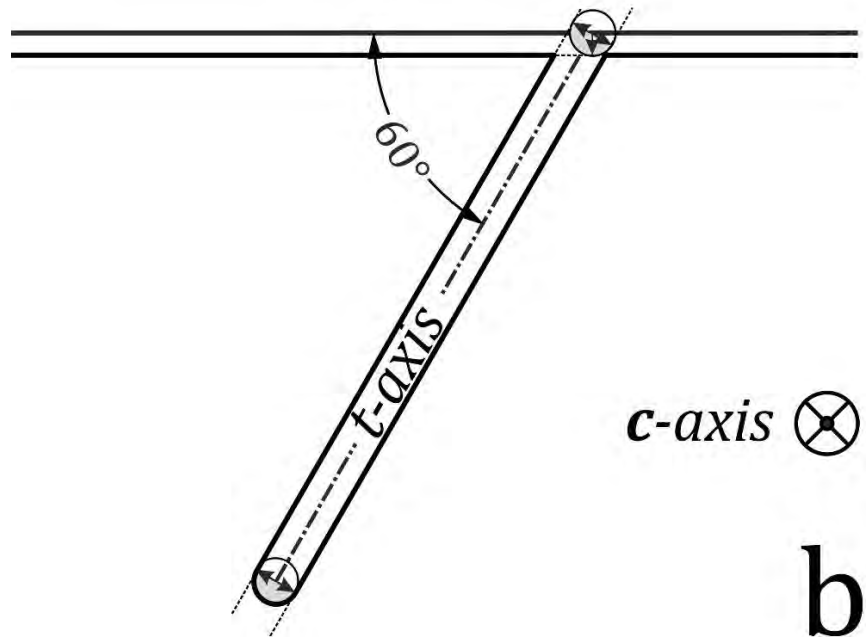
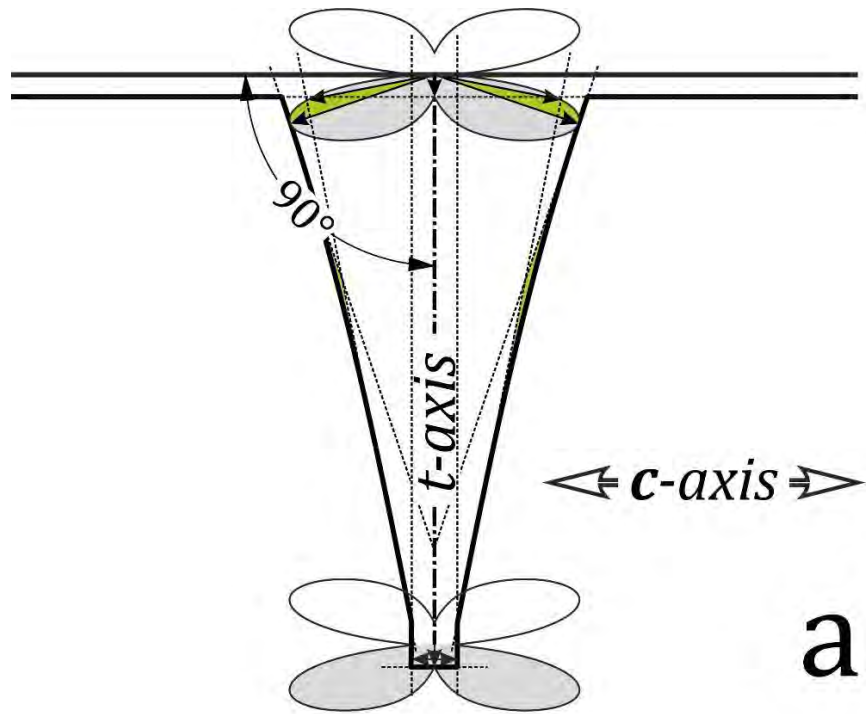


Figure 6

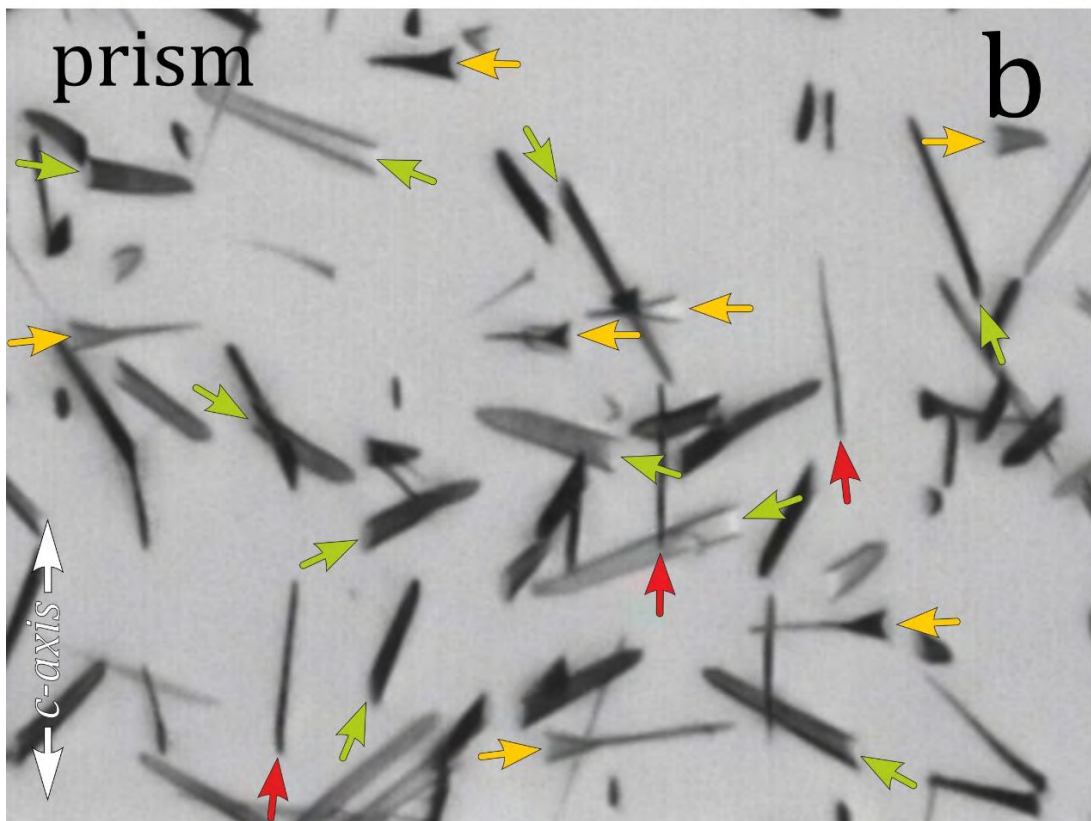
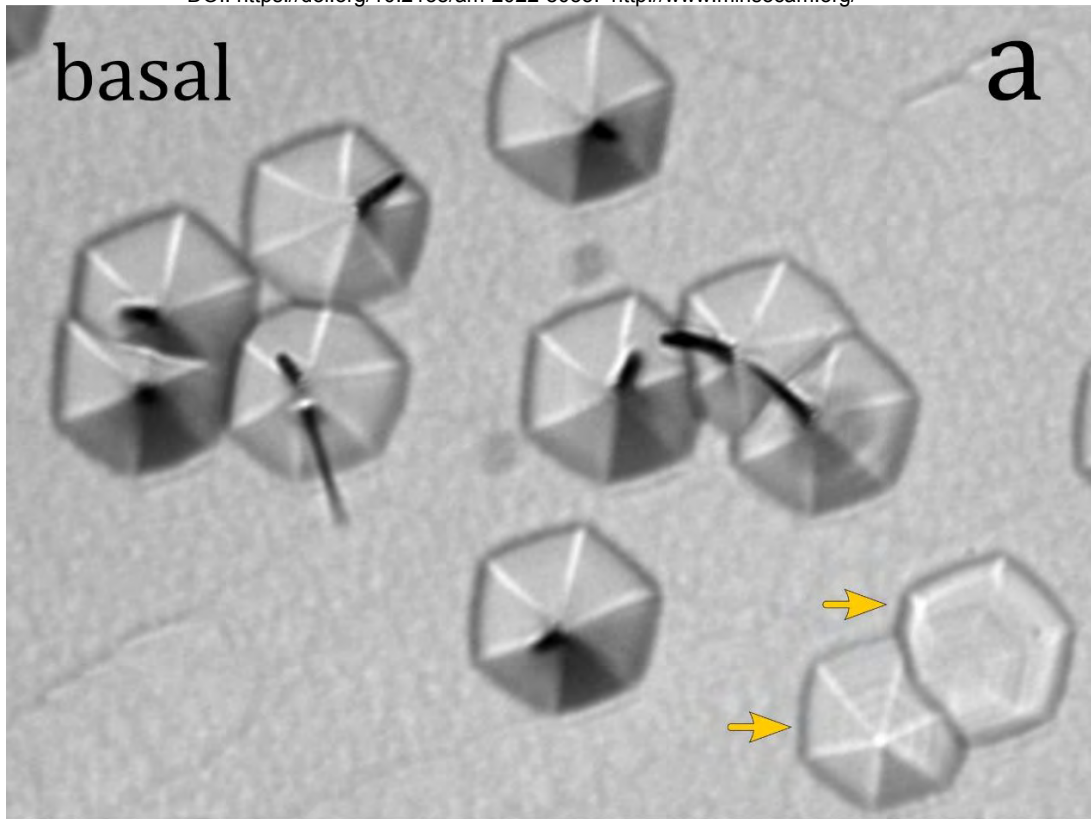


Figure 7

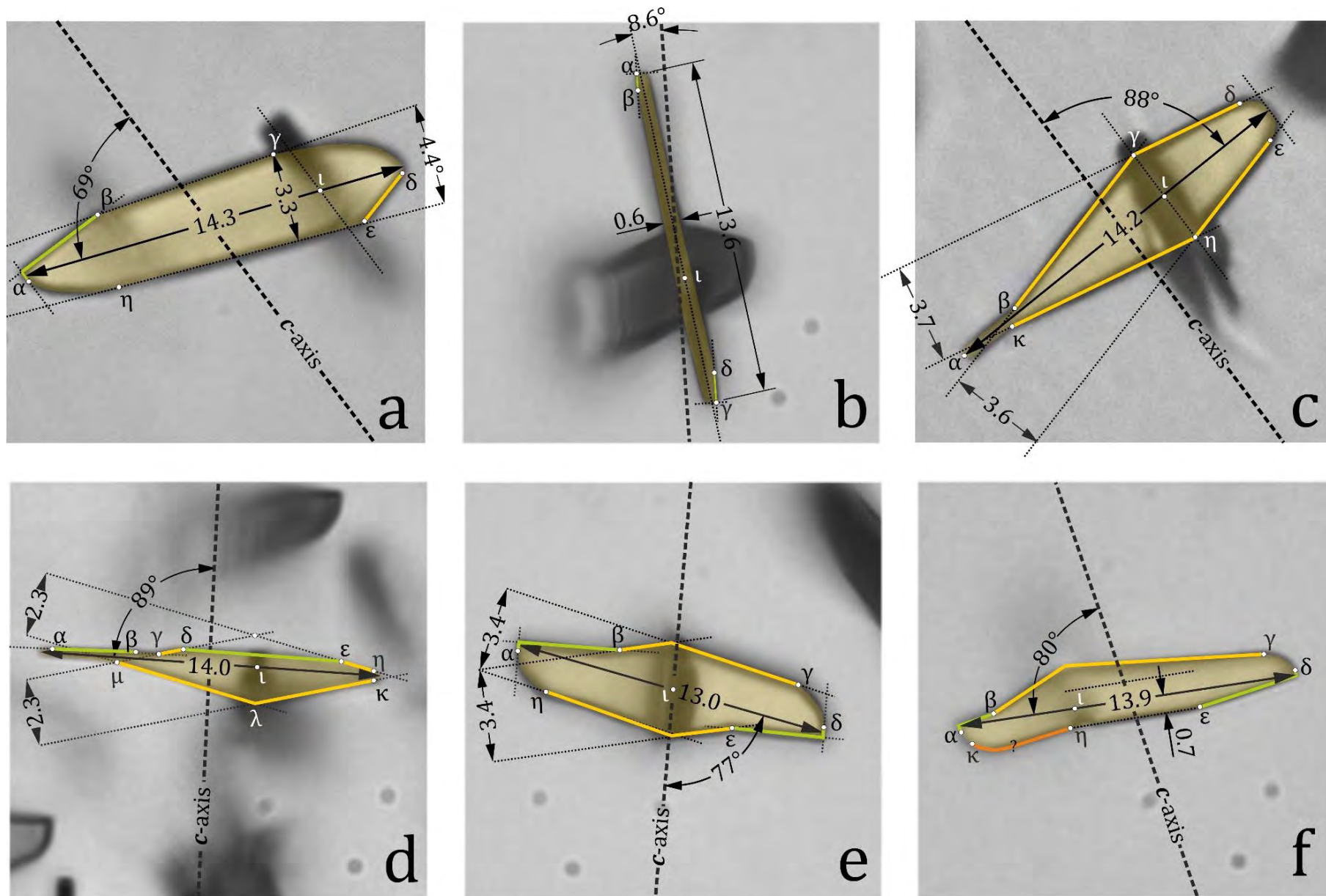


Figure 8

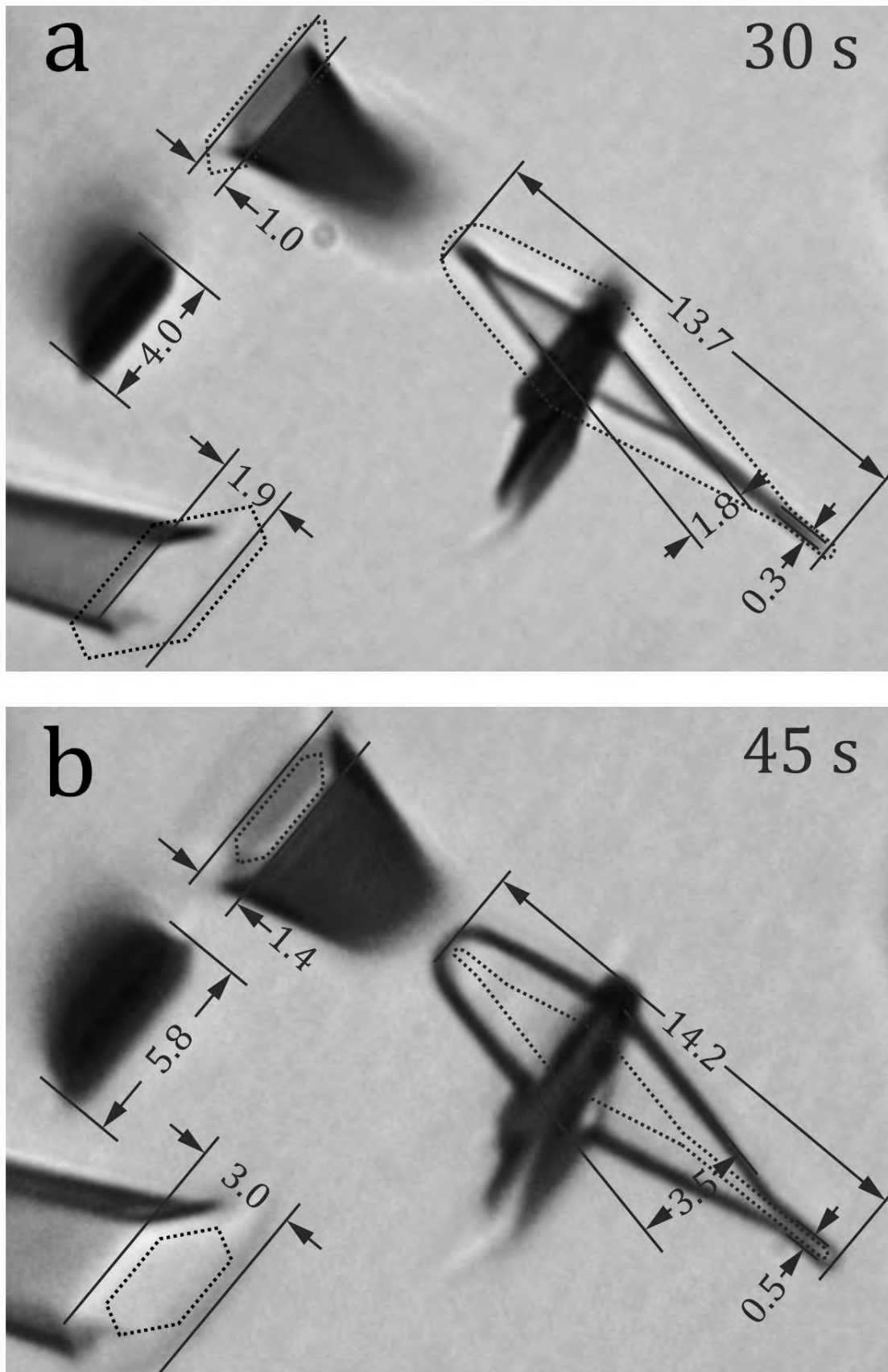


Figure 9